



Docket No.: 49657-961

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Application of

Kenji ITOGA, et al.

Serial No.: 09/769,490

Group Art Unit: 2882

Filed: January 26, 2001

Examiner: C. Kao

For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE

#20/et.  
MR  
8/29/03

**PETITION FOR EXTENSION OF TIME**

Mail Stop Extension of Time  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RECEIVED  
JUL 30 2003  
TECHNOLOGY CENTER 2800

Sir:

It is respectfully requested that the time for response to the Office Action dated March 27, 2003, now due to expire June 27, 2003, be extended for one (1) month and set to expire on Sunday, July 27, 2003 (Monday July 28, 2003).

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: July 28, 2003

07/29/2003 ANA 0000032 500417 06469660 11000 20000000 11000 00.011 DA 151:1251 01 FC:1251